

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of: Han et al. | Group Art Unit: 1775 |
| Application No: 10/824,123 Confirmation No: 6448 | Examiner: Michael E. Lavilla |
| Filed: April 13 th , 2004 | Attorney Docket No: |
| Title: PROCESS CHAMBER COMPONENT HAVING ELECTROPLATED YTTRIUM CONTAINING COATING | 003330 P01 USA/ETCH/METAL/MD |
| | July 10 th , 2007 San Francisco, California |

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

VIA ELECTRONIC FILING

Examiner Lavilla:

O.K.
to Enter
8/3/07
AEJ

This communication is in response to the Office Communication mailed on April 5th, 2007, and is being filed with a petition for a one-month extension of time and authorization to charge deposit account for the requisite fee of \$120 under 37 C.F.R. § 1.17(a)(1).

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~~7/11/07~~